

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Koops et al

Title: Procedure for etching of materials at the surface with focussed electron beam induced chemical reaction at said surface

Filing Date: July 28, 2003

Serial No. : 10/628,174

Examiner: Allan W. Olsen

Group Art Unit: 1792

Attorney Docket No.: 8183

Date: May 28, 2008

Confirmation no. 5591

**NOTICE OF APPEAL FROM THE EXAMINER TO THE  
BOARD OF PATENT APPEALS AND INTERFERENCES**

Now comes the applicant by and through its attorneys and hereby appeals the final rejection of claims 45-68 in the application. Claims 45-68 of the application were finally rejected in a final office action dated January 28, 2008.

The Notice of Appeal fee is being paid electronically. Please charge deposit account 23-3060 for any fee deficiency and please credit any overpayment to said account.

Respectfully submitted,

Woodling, Krost and Rust

/Kenneth L. Mitchell/

Kenneth L. Mitchell  
Ohio Bar Reg. No. 31587  
Florida Bar Reg. No. 382531  
Patent Attorney, Reg. No. 36,873  
Registered Professional Engineer, Reg. No.54455  
Woodling, Krost and Rust  
9213 Chillicothe Road  
Kirtland, Ohio 44094  
phone nos. 866-241-4150 (toll free), 440-256-4150;  
fax nos. 866-241-4043 (toll free), 440-256-7453;  
cell no. 440-487-2694  
[clevepat@aol.com](mailto:clevepat@aol.com)  
[clevepat@sbcglobal.net](mailto:clevepat@sbcglobal.net)